

<b>Notice of References Cited</b>	Application/Control No. 10/060,549		Applicant(s)/Patent Under Reexamination OETTINGER ET AL.	
	Examiner David S. Kim		Art Unit 2613	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,119,225 A	06-1992	Grant et al.	398/123
*	B	US-5,592,320 A	01-1997	Wissinger, Alan B.	398/121
*	C	US-5,953,146 A	09-1999	Shelby, Kevin Alan	398/131
*	D	US-5,973,310 A	10-1999	Lunscher, Wolfram	250/203.1
*	E	US-6,381,055 B1	04-2002	Javitt et al.	398/131
*	F	US-2002/0097472 A1	07-2002	Oettinger et al.	359/172
*	G	US-6,469,815 B1	10-2002	Poon et al.	398/131
*	H	US-6,483,621 B1	11-2002	Adams et al.	398/130
*	I	US-2002/0181055 A1	12-2002	Christiansen et al.	359/159
*	J	US-2003/0043435 A1	03-2003	Oettinger et al.	359/159
*	K	US-6,556,324 B1	04-2003	Meier, Carsten	398/129
*	L	US-6,577,421 B1	06-2003	Cheng et al.	398/129
*	M	US-2005/0276608 A1	12-2005	Pavelchek, Andrew	398/135

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.